



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takeshi KIJIMA et al.

Group Art Unit: 2812

Application No.: 10/722,422

Examiner: S. GEYER

Filed: November 28, 2003

Docket No.: 117897

For: METHOD OF MANUFACTURING CERAMIC FILM, METHOD OF  
MANUFACTURING FERROELECTRIC CAPACITOR, CERAMIC FILM,  
FERROELECTRIC CAPACITOR, AND SEMICONDUCTOR DEVICE

**AMENDMENT UNDER 37 C.F.R. §1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the August 17, 2006 Office Action, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**